

METHOD, APPARATUS AND ARTICLE FOR MICROFLUIDIC CONTROL VIA  
ELECTROWETTING, FOR CHEMICAL, BIOCHEMICAL AND BIOLOGICAL  
ASSAYS AND THE LIKE

BACKGROUND OF THE INVENTION

5    Field of the Invention

This disclosure is generally related to the manipulation of fluids, for example, manipulating fluids for performing chemical, biochemical, cellular and/or biological assays, and more particularly to electrowetting to manipulate electrolytic fluids, for example reactants such as agents and reagents.

10   Description of the Related Art

Two of the primary factors currently driving the development of microfluidic chips for pharmaceuticals, the applied life sciences, and medical diagnostics include: (1) the reduction of sample volumes to conserve expensive reagents and reduce disposal problems; and (2) the reduction of test turnaround  
15 times to obtain laboratory results. Through the engineering of new processes and devices, time-consuming preparatory procedures and protocols can be automated and/or eliminated. This has been the motivation behind the development of microfluidics associated with lab-on-a-chip systems, biochips, and micro Total Analytical Systems ( $\mu$ TAS). The result has been a large number of mechanical  
20 designs for pumps, valves, splitters, mixers, and reactors that have been micro-fabricated in channels using photolithographic and other bonding and assembly methods.

There is also a growing need in the fields of chemistry, biochemistry and biology for performing large scale, combinatorial testing. One type of large-  
25 scale combinatorial testing employs microarrays. Each microarray consists of hundreds or thousands of spots of liquid applied to a slide or "biochip." Each spot may, for example, contain a particular DNA segment. The microarrays are created

using robots which move pins to wick up the appropriate fluid from reservoirs and to place each individual spot of fluid precisely on the slide. The hardware is expensive and the slides are time consuming to manufacture.

## BRIEF SUMMARY OF THE INVENTION

5                   In one aspect, a microfluidic system comprises microfluidic system; an array of drive electrodes carried by the substrate; a dielectric carried by the substrate, overlying at least a portion of the array of drive electrodes; a fluid compatibility layer overlying the array of drive electrodes; and at least one ground electrode carried by the substrate, overlying at least a portion of the dielectric to  
10   provide a ground potential to at least one fluidic body.

                  In another aspect, a method of forming a microfluidic structure for manipulating at least one fluid body comprises providing a first plate; forming an array of drive electrodes overlying at least a portion of the first plate, the drive electrodes having a dimension less than a lateral dimension of the at least one  
15   fluid body; forming a fluid compatibility layer overlying the array of drive electrodes; and forming at least one ground electrode carried by the substrate and positioned to provide a ground potential to the at least one fluid body.

                  The microfluidic platform may provide a low cost and efficient method and apparatus for the pharmaceutical industries to perform drug-screening  
20   applications. The microfluidic platform may also provide a low cost and efficient method and apparatus for the chemical industries to perform combinatorial chemistry applications. The microfluidic platform may additionally provide a low cost and efficient method and apparatus for the bioscience industries to perform gene expression microarray research. The microfluidic platform may further  
25   provide a low cost and efficient method and apparatus for clinical diagnostic bioassay, as well as lead to additional "lab-on-a-chip" applications. Eliminating the top plate or cover from the microfluidic platform may, for example, allow the depositing of samples via an array of pipettes or other automated deliver systems,

and/or the use of standard video equipment to focus on the active surface to track positions of fluid bodies.

## BRIEF DESCRIPTION OF THE SEVERAL VIEWS OF THE DRAWINGS

In the drawings, identical reference numbers identify similar elements or acts. The sizes and relative positions of elements in the drawings are not necessarily drawn to scale. For example, the shapes of various elements and angles are not drawn to scale, and some of these elements are arbitrarily enlarged and positioned to improve drawing legibility. Further, the particular shapes of the elements as drawn, are not intended to convey any information regarding the actual shape of the particular elements, and have been solely selected for ease of recognition in the drawings.

Figure 1 is a schematic diagram of a microfluidic control system, including a controller in the form of a computing system, and a microfluidic platform having a microfluidic structure including a two-dimensional matrix array of drive electrodes, row and column driving circuits and a ground electrode.

Figure 2 is a schematic diagram of the computing system and microfluidic platform of Figure 1.

Figure 3 is a cross-sectional view of one illustrated embodiment of a microfluidic structure.

Figure 4 is a first alternative illustrated embodiment of the microfluidic structure, having transistors formed in a plane of the drive electrodes.

Figure 5 is a second alternative illustrated embodiment of the microfluidic structure, omitting a second substrate and incorporating at least one ground electrode into a first substrate.

Figure 6 is an isometric view of the microfluidic structure, illustrating the two-dimensional matrix array of electrodes, the array of transistors electrically coupled to respective ones of the electrodes, and the gate and source lines for driving the transistors.

Figure 7 is an isometric view of a portion of the microfluidic structure of Figure 6, having the second plate raised to more fully illustrate the geometry of one of the bodies of fluid received in the cavity or interior of the microfluidic structure.

5                    Figures 8A-8E are cross-sectional views of successive steps in fabricating the microfluidic structure.

Figure 9 is a schematic view of the microfluidic system illustrating one exemplary embodiment a feedback subsystem employing a set of visual sensors.

10                  Figure 10 is a schematic view of the microfluidic system illustrating another exemplary embodiment a feedback subsystem employing a set of capacitively or resistively sensitive sensors.

Figure 11 is a flow diagram of one exemplary illustrated method of operating the microfluidic system, including producing an animation executable file  
15                  using animation software.

Figure 12 is a flow diagram of an additional method of operating the microfluidic system including determining a position of a fluid body via the position feedback subsystem and displaying the actual position and/or flow path of the fluid body, and or a desired position and/or flow path of the fluid body.

20                  Figure 13 is a flow diagram of a further method of operating the microfluidic system including employing the position feedback subsystem to adjust the operation of the microfluidic system based on position feedback.

Figure 14 is a flow diagram of an even further method of operating the microfluidic system including converting position feedback from the position  
25                  feedback subsystem into an animation of an actual flow path.

Figure 15 is a schematic diagram of a screen display on an active matrix display of a set of desired flow paths, actual flow paths, desired positions and actual positions for a two bodies of fluid in the microfluidic structure.

Figure 16A is an isometric view of a portion a microfluidic structure  
30                  comprising a substrate, a number of electrodes carried by the substrate, a

dielectric layer overlying the electrodes, a number of ground electrodes with an exposed surface flush with an exposed surface of a fluid compatibility layer carried by the dielectric layer.

Figure 16B is a cross-sectional view of a portion a microfluidic structure comprising a substrate, a number of electrodes carried by the substrate, a dielectric layer overlying the electrodes, a number of ground electrodes underlying a fluid compatibility layer carried by the dielectric layer.

Figure 16C is a cross-sectional view of a portion a microfluidic structure comprising a substrate, a number of electrodes carried by the substrate, a dielectric layer overlying the electrodes, a number of ground electrodes overlying a fluid compatibility layer carried by the dielectric layer.

Figure 16D is an isometric view of a portion a microfluidic structure comprising a substrate, a number of electrodes carried by the substrate, a fluid compatibility layer carried by the substrate, and a number of ground electrodes with an exposed surface flush with an exposed surface of a fluid compatibility layer.

Figure 17A is a top plan view of a portion of a microfluidic structure where the ground electrodes extend parallel along columns formed by the electrodes and overlie a portion of the electrodes.

Figure 17B is a top plan view of a portion of a microfluidic structure where the ground electrodes extend parallel along columns formed by the electrodes and do not overlie a portion of the electrodes.

Figure 17C is a top plan view of a portion of a microfluidic structure where the ground electrodes extend parallel along columns formed by the electrodes and partially overlie a portion of the electrodes.

Figure 18A is a top plan view of a portion of a microfluidic structure where the ground electrodes extend parallel along rows formed by the electrodes and overlie a portion of the electrodes.

Figure 18B is a top plan view of a portion of a microfluidic structure where the ground electrodes extend parallel along rows formed by the electrodes and do not overlie a portion of the electrodes.

Figure 18C is a top plan view of a portion of a microfluidic structure  
5 where the ground electrodes extend parallel along rows formed by the electrodes and partially overlie a portion of the electrodes.

Figure 19A is a top plan view of a portion of a microfluidic structure where the ground electrodes extend parallel along both columns and rows formed by the electrodes and overlie a portion of the electrodes.

10 Figure 19B is a top plan view of a portion of a microfluidic structure where the ground electrodes extend parallel along both columns and rows formed by the electrodes and do not overlie a portion of the electrodes.

Figure 19C is a top plan view of a portion of a microfluidic structure where the ground electrodes extend parallel along both columns and rows formed  
15 by the electrodes and partially overlie a portion of the electrodes.

## DETAILED DESCRIPTION OF THE INVENTION

In the following description, certain specific details are set forth in order to provide a thorough understanding of various embodiments of the invention. However, one skilled in the art will understand that the invention may be  
20 practiced without these details. In other instances, well-known structures associated with matrix arrays such as those used in active matrix displays, thin film transistors, voltage sources, controllers such as microprocessors and/or computing systems, photolithography, micro-fabrication, and animation software have not been shown or described in detail to avoid unnecessarily obscuring descriptions of  
25 the embodiments of the invention.

Unless the context requires otherwise, throughout the specification and claims which follow, the word "comprise" and variations thereof, such as, "comprises" and "comprising" are to be construed in an open, inclusive sense, that is as "including, but not limited to."

The headings provided herein are for convenience only and do not interpret the scope of meaning of the claimed invention.

Figure 1 shows a microfluidic system 10 having a microfluidic platform 11 including a microfluidic structure 12 and a controller such as a computing system 14 coupled to control the microfluidic structure 12. The microfluidic structure 12 includes at least one port 16a for providing fluid communication between an exterior 18 and an interior 20 of the microfluidic structure 12. The port 16a permits the addition and/or removal of one or more fluids 22a, 22b to the interior 20 of the microfluidic structure 12 after manufacture and during use of the microfluidic structure 12. In some embodiments, the microfluidic structure 12 includes a separate inflow port 16a and outflow port 16b. The microfluidic structure 12 may further include one or more valves 24a, 24b for controlling the flow of fluids through the respective ports 16a, 16b.

The microfluidic structure 12 includes an array of drive electrodes 26. In one embodiment illustrated in Figure 1, the array of drive electrodes 26 takes the form of a two-dimensional matrix array. The two-dimensional matrix of drive electrodes 26 allows movement of the fluids via electrowetting in any direction on the microfluidic structure 12, without dedicated hardware defined flow paths. This provides significantly increased flexibility in use over microfluidic structures 12 having hardware defined flow paths, and may be less costly to manufacture since it allows the use of well-developed techniques from the field of active matrix display fabrication and control. In another embodiment, the array of drive electrodes 26 describes specific hardware defined flow paths, such that the fluids 22a, 22b can only move along the prescribed flow paths. As discussed above, microfluidic structures 12 employing hardware defined flow paths may not be as advantageous as those employing two-dimensional matrix arrays of drive electrodes 26 but may realize other advantages such as maintaining sample purity and/or avoiding sample evaporation.

The microfluidic structure 12 may also include a row driving circuit 28 and a column driving circuit 30 to drive the drive electrodes 26. In the embodiment

illustrated in Figure 1, the row and column driving circuits 28, 30 are formed "on chip," as part of the microfluidic structure 12, while in alternative embodiments the row and column driving circuits 28, 30 are located off of the chip, for example, as a portion of an off chip controller such as the computing system 14 or discrete drive controller (not illustrated).

In some embodiments, the microfluidic structure 12 may further include one or more ground electrodes 32, spaced perpendicularly from the array of drive electrodes 26. The ground electrode 32 provides a ground potential to the body of fluid 22a, 22b.

The microfluidic structure 12 may take advantage of well-developed technologies associated with the visual display of information and, in particular, the thin film transistor ("TFT") active matrix liquid crystal displays ("LCD") that have come to dominate the flat panel display market. For example, existing electrode (*i.e.*, pixel) addressing schemes, frame times, frame periods, display formats (*e.g.*, SXGA, UXGA, QSXGA, ...NTSC, PAL, and SECAM), electrode spacing and size, use of transparent Indium Tin Oxide ("ITO") as the ground electrode 32, the magnitude and alternating sign of the applied potentials, and the gap dimension between the electrodes are all suitable for the microfluidic structure 12. Existing photolithographic micro-fabrication methods can be used to create drive electrodes 26 ranging from an upper length dimension of approximately 1 millimeter down to approximately 10 micrometers for transmissive mode polysilicon TFTs. This range of scales will allow manipulation of fluid bodies 22 ranging in volume from several microliters down to picoliter volumes, respectively. Thus, the invention can take advantage of existing active matrix LCD technology including fabrication techniques and animation software including commercially available video generation or editing software to develop a microfluidic platform 10 for controlling the motion of fluid droplets via electrowetting droplet control physics.

The array of drive electrodes 26 and/or ground electrode 32 is driven to manipulate samples or bodies of fluid 22a, 22b to perform chemical, biochemical, or cellular/biological assays. The fluid quantities can be divided,



combined, and directed to any location on the array 26. The motion of the fluid bodies 22a, 22b is initiated and controlled by electrowetting. This phenomenon is a result of the application of an electric potential between a body of fluid 22a, 22b such as a drop or droplet and a drive electrode 26 that is electrically insulated from the body of fluid 22a, 22b by a thin solid dielectric layer (illustrated in Figures 3-7). This locally changes the contact angle between the body of fluid 22a, 22b and the surface of the dielectric layer, resulting in a preferential application to one side of the fluid body 22a, 22b providing unbalanced forces parallel to the surface. The unbalanced forces result in motion of the fluid body 22a, 22b.

10               The use of electrodes 26, 32 and thin film technology to utilize electrowetting to arbitrarily manipulate bodies of fluid 22a, 22b is potentially revolutionary. The microfluidic structure 12 requires no moving parts while taking advantage of the most dominant forces that exist at the small scales: capillary forces. Microfluidic devices designed to utilize a continuous volume of liquid can be disrupted by the presence of bubbles in microchannels (e.g., use of syringe pumps or other positive displacement pumps). In contrast, the use of interfacial surface tension is consistent with the typical assay requirement that discrete fluid samples be delivered, mixed, reacted, and detected.

20               Figure 2 is a detailed view of one illustrated embodiment of the microfluidic system 10.

              The computing system 14 includes a number of subsystems, such as a processor 34, system memory 36, system bus architecture represented by arrows 38 coupling the various subsystems. The system memory 36 may include read only memory ("ROM") 40, and/or random access memory ("RAM") 42 or other dynamic storage that temporarily stores instructions and data for execution by the processor 36.

              The computing system 14 typically includes one or more computer-readable media drives for reading and/or writing to computer-readable media. For example, a hard disk drive 44 for reading a hard disk 46, an optical disk drive 48

for reading optical disks such as CD-ROMs or DVDs 50 and/or a magnetic disk drive 52 for reading magnetic disks such as floppy disks 54.

The computing system 14 includes a number of user interface devices, such as an active matrix display 56, keyboard 58 and mouse 60. A display adapter or video interface 62 may couple the active matrix display 56 to the system bus 38. An interface 64 may couple the keyboard 58 and mouse to the system bus 38. The mouse 60 can have one or more user selectable buttons for interacting with a graphical user interface ("GUI") displayed on the screen of the active matrix display 56. The computing system 14 may include additional user interface devices such as a sound card (not shown) and speakers (not shown).

The computing system 14 may further include one or more communications interfaces. For example, a modem 66 and/or network interface 68 for providing bi-directional communications over local area networks ("LAN") 70 and/or wide area networks (WAN) 72, such extranets, intranets, or the Internet, or via any other communications channels.

The computing system 14 can take any of a variety of forms, such as a micro- or personal computer, a mini-computer, a workstation, or a palm-top or hand-held computing appliance. The processor 34 can take the form of any suitable microprocessor, for example, a Pentium II, Pentium III, Pentium IV, AMD Athlon, Power PC 603 or Power PC 604 processor. The computing system 14 is illustrative of the numerous computing systems suitable for use with the present invention. Other suitable configurations of computing systems will be readily apparent to one of ordinary skill in the art. Other configurations can include additional subsystems, or fewer subsystems, as is suitable for the particular application. For example, a suitable computing system 14 can include more than one processor 34 (*i.e.*, a multiprocessor system) and/or a cache memory. The arrows 38 are illustrative of any interconnection scheme serving to link the subsystems. Other suitable interconnection schemes will be readily apparent to one skilled in the art. For example, a local bus could be utilized to connect the processor 34 to the system memory 36 and the display adapter 62.

The system memory 36 of the computing system 14 contains instructions and data for execution by the processor 34 for implementing the illustrated embodiments. For example, the system memory 36 includes an operating system ("OS") 74 to provide instructions and data for operating the computing systems 14. The OS 74 can take the form of conventional operating systems, such as WINDOWS 95, WINDOWS 98, WINDOWS NT 4.0 and/or WINDOWS 2000, available from Microsoft Corporation of Redmond, Washington. The OS 74 can include application programming interfaces ("APIs") (not shown) for interfacing with the various subsystems and peripheral components of the computing system 14, as is conventional in the art. For example, the OS 74 can include APIs (not shown) for interfacing with the active matrix display 56, keyboard 58, windowing, sound, and communications subsystems.

The system memory 36 of the computing system 14 can also include additional communications or networking software (not shown) for wired and/or wireless communications on networks, such as LAN 70, WAN or the Internet 72. For example, the computing system 14 can include a Web client or browser 76 for communicating across the World Wide Web portion of the Internet 72 using standard protocol (e.g., Transmission Control Protocol/Internet Protocol (TCP/IP), User Datagram Protocol (UDP)). A number of Web browsers are commercially available, such as NETSCAPE NAVIGATOR from America Online, and INTERNET EXPLORER available from Microsoft of Redmond, Washington.

The system memory 36 of the computing system 14 may also include instructions and/or data in the form of application programs 78, other programs and modules 80 and program data 82 for operation of the microfluidic platform and providing information therefrom, as discussed in detail below. The instructions may be preloaded in the system memory 36, for example in ROM 40, or may be loaded from other computer readable media 46, 50, 54 via one of the media drives 44, 48, 52.

Also as illustrated, the microfluidic platform 10 includes an interface 84 for providing communications between the computing system 14 and the

various subsystems of the microfluidic platform such as a feedback subsystem 86, row driver 28 and column driver 30. The microfluidic platform also includes one or more voltage sources 88 for providing a potential to the drive electrodes 26 and/or ground electrode 32 in accordance with drive instructions supplied to the row and column drivers 28, 30 by the computing system 14. While shown as part of the microfluidic structure 12, in some embodiments the voltage source 88 may be a discrete component, electrically couplable to the microfluidic platform 10 and/or microfluidic structure 12.

Figure 3 shows a cross-section of a portion of the microfluidic structure 12 corresponding to a single addressable element (*i.e.*, pixel).

The microfluidic structure 12 includes first and second substrates 102, 104, spaced apart to form an interior or cavity 106 therebetween, and an exterior 108 thereout. The substrates 102, 104 may take the form of glass plates, and may include a sodium barrier film 110a-110d, on opposed surfaces of the respective substrates plates. The sodium barrier film may be applied to the substrate via sintering or via atmospheric pressure chemical vapor disposition ("APCVD") for example using a SierraTherm 5500 series APCVD system.

A gate insulator 112 may be formed overlying the sodium barrier 110b on the interior surface of the first substrate 102. The array of drive electrodes 26 are formed on the gate insulator layer 112. The drive electrodes 26 may be transparent, for example being formed of transparent ITO. An array of transistors 114 (only one illustrated in Figure 3) may also be formed on the gate insulator layer 112. The transistors 114 are electrically coupled to respective ones of the drive electrodes 26 for controlling the same. The transistors 114 may be thin film transistors formed via well-known thin film fabrication processes. A dielectric layer 116 is formed over the drive electrodes 26 and the transistors 114 to provide appropriate dielectric capacitance between the drive electrodes 26 and the bodies of fluid 22a, 22b. The dielectric layer 116 should be sufficiently thin to provide proper capacitance, yet not have pin holes which could cause electrical shorting. While the Figure illustrates the transistors 114 at a corner of each of the drive

electrodes 26, the transistors 114 can be located at other locations as will be apparent to one of skill in the art.

One or more ground electrodes 32 may overlay the second glass substrate 104, for example, being formed over the sodium barrier film 110d on the interior surface of the second substrate 104. The ground electrode 32 may be transparent, for example, being formed of transparent ITO. This allows visual inspection of the microfluidic operation, which may be advantageously used with at least one embodiment of the feedback subsystem 86, as is discussed in detail below.

The microfluidic structure 12 may include at least one fluid compatibility layer 118 forming at least a portion of the cavity 106. The fluid compatibility layer 118 is formed of a fluid compatibility material, that is a material having appropriate physico-chemical properties for the fluid or assay of interest. For example, the selected fluid compatibility material should have appropriate hydrophobicity or hydrophylicity to prevent the chemical solutions from reacting with the fluid compatibility layer 118. From this perspective, it is unlikely that the use of polyimide coatings that are used in LCD systems will be useful for assays of interest. A Teflon or other hydrophobic coating will likely be required. The fluid compatibility material may be spaced from the electrodes 26, 32 by one or more intervening layers, such as the fluid compatibility layer 118a spaced from the drive electrodes 26 by the dielectric layer 116. Alternatively, the electrodes 26, 32 may be directly coated with the fluid compatibility material, such as the fluid compatibility layer 118b directly coating the ground electrode 32 in Figure 3. In a further alternative, the microfluidic structure 12 may omit the fluid compatibility layer 118a, where the dielectric layer 116 has suitable fluid compatibility characteristics, such as hydrophylicity.

In the manufacture of LCD displays, the TFT/electrode plate and the ITO/color filter plate are epoxy bonded with spacers. A vacuum is used to fill the gap with the liquid crystal material and an epoxy plug seals the liquid crystal material from the surroundings. As discussed above, the microfluidic structure 12

includes a number of fluid inlet and outlet ports 16a, 16b, respectively (Figure 1), which may be inserted at the edges of the substrates during the bonding step. A number of port designs may be used, and may include distinct or integrally formed valves 24a, 24b such as a septum, capillary, or other valve to control flow of fluids 22a, 22b through the ports 16a, 16b after completion of the manufacturing process, for example, before or during use by the end user. The microfluidic structure 12 may also contain an immiscible fluid 121, for example air or some other immiscible fluid. The microfluidic structure 12 may also incorporate humidity control since small bodies of fluids (*i.e.*, droplets) 22a, 22b will rapidly evaporate if conditions near saturation are not used. Alternatively, or additionally, rather than carefully controlling humidity, another fluid 121 may be used in lieu of air to prevent evaporation.

Thus, the principle modifications to an LCD design to achieve a microfluidic structure 12 involves (1) the omission of the liquid crystal material that normally resides in displays; (2) placement of appropriate layers to provide dielectric capacitance, chemical protection and hydrophobicity for the samples of interest, in lieu of the polyimide orientation layers used for displays; (3) placement of a protective overcoat immediately above the transparent ITO electrode with no other color filters or polarizing films required; and/or (4) the inclusion of one or more ports and/or valves to permit placement and or removal of individual bodies of fluid 22a, 22b surrounded by air or other immiscible fluid into the region where the liquid crystal material normally resides in displays.

Figure 4 shows a first alternative embodiment of the microfluidic structure 12, where the transistor is formed within the plane of the drive electrode 26, and the dielectric layer 116 is thinner than the dielectric layer 116 illustrated in Figure 3. Thus, where the embodiment of Figure 3 has a different electrowetting force at the transistor 114 than at the drive electrode 26 spaced from the transistor 114, the embodiment of Figure 4 is capable of a more uniform electrowetting force. The thinner dielectric layer 116 provides for a larger change in the contact angle, allowing easier movement of the bodies of fluid 22a, 22b. While other

permutations are possible, it is desirable to maintain a substantially flat surface 118a to avoid adversely impacting fluid motion.

Figure 5 shows a second alternative embodiment, of the microfluidic structure 12 omitting the ground electrode 32, as well as the second plate 104 and associated sodium barrier films 110c, 110d. Omission of the second plate 104, ground electrode 32 and associated barrier films 110c, 110d allows the microfluidic structure 12 to mate with existing robotic, ink-jet printer, and DNA micro-array printing technologies. Special attention to avoid rapid evaporation may be required in the embodiment of Figure 5. The bodies of fluid 22a, 22b may be grounded via contact with a ground electrode 32 carried by the substrate 102, or the potentials of the bodies of fluid 22a, 22b may be allowed to float. In such a design, the bodies of fluid 22 are capacitively coupled to the drive electrodes 26 and any leakage across the dielectric can be averaged to ground by employing an A/C drive signal to the drive electrodes 26. In such a case, any leakage across the dielectric 116 will be averaged to ground where the drive voltage alternates polarity.

Figures 6 and 7 show the arrangement of drive electrodes 26 and TFT transistors 114 in the microfluidic structure 12, as well as, a number of gate lines 119a and source lines 119b (*i.e.*, rows and columns lines) coupled to the gates and sources (not illustrated in Figures 6 and 7) of respective ones of the transistors 114. The fluid compatibility layer 118a has been omitted from Figures 5 and 6 for clarity of illustration. Figure 7 also illustrates the geometry of a fluid body 22 received in the cavity between the fluid compatibility layers 118a, 118b overlying the substrates 102, 104, respectively. The fluid bodies 22a, 22b may be moved along a flow path by varying the respective potential applied to different portions of the dielectric layer 116 overlying respective ones of the drive electrodes 26.

Figures 8A-8E illustrate an exemplary method of fabricating the microfluidic structure 12 of Figures 3-5, in sequential fashion. In the interest of brevity, a number of intervening deposition, masking and etching steps to form the various layers and specific structures are not illustrated, but would be readily

apparent to those skilled in the art of silicon chip fabrication and particularly the art of TFT fabrication.

In particular, Figure 8A shows a gate metal layer 120 on the glass substrate 102, after deposition, masking and etching to form the gate of the transistor 114. The sodium barrier layer 110b is omitted from the illustration for clarity. Figure 8B shows the deposition of the gate insulator layer 112, an amorphous silicon layer 122 and a positively doped amorphous silicon layer 124. Figure 8C shows the deposition of the source/drain metal layer 126 for forming the source 126a and drain 126b of the transistor 114, and a trench 128 etched in the source/drain metal layer 122 and the doped amorphous silicon layer 124 over the gate metal layer 120 to form the gate 130. Figure 8D shows the formation of the drive electrodes 26 which typically includes at least deposition, masking and etching steps. Figure 8E shows the formation of the dielectric layer 116 overlying the drive electrode array 26 and transistor array 114 and fluid compatible layer 118a overlying the dielectric layer 116.

Figures 16A and 17A each show portions of an embodiment of a microfluidic structure 12 comprising a single substrate 102, sodium barrier films 110a, 110b on opposed surfaces of the substrate 102, a number of drive electrodes 26 carried by the substrate 102, and a dielectric layer 116 overlying the drive electrodes 26. A number of electrically conductive ground electrodes 32 extend parallel, along columns formed by the drive electrodes 26. Each of the ground electrodes 32 overlies a portion of the drive electrodes 26 in a respective one of the columns of drive electrodes 26, and is electrically insulated therefrom via the dielectric layer 116. This embodiment advantageously eliminates the top or cover plate (second substrate 104, Figure 3), allowing direct and easy access to the fluid compatibility layer 118 for depositing materials such as fluids. For example, leaving the microfluidic structure 12 open allows access by automated equipment, such as fluid dispensers employing arrays of pipettes, or may allow direct access to any point on the fluid compatibility layer 118 by one or more depositing devices.



Suitable materials for the ground electrodes 32 may include ITO, chromium, gold, nickel and/or other conductor materials. The dimensions and pitch of the ground electrodes 32 should be sufficiently closely spaced to ensure that the fluid bodies 22 will always contact at least one ground electrode 32. The  
5 width of the ground electrodes 32 should be sufficiently small that the contour length of the fluid body contact line that is in contact with the ground electrode 32 is a small fraction of the entire contour length of the fluid body contact line. Thus, if the drive electrodes 26 are approximately 1mm on a side, suitable dimensions for the ground electrodes 32 may be hundreds of angstroms thick and tens of microns  
10 wide. Centering the ground electrodes 32 over respective drive electrodes 26 may reduce or prevent interference between the ground electrodes 32, and/or transistors 114, if any.

A fluid compatibility layer 118a (e.g., Teflon commercially available from E.I. du Pont de Nemours and Company) is carried by the dielectric layer 116.  
15 An exposed surface 33 of the ground electrodes 32 is coplanar with an exposed surface 117 of fluid compatibility layer 118a, to allow direct electrical contact between the ground electrodes 32 and the fluid bodies 22. Such can be achieved through standard deposition (e.g., spin coating, sputtering, evaporation, chemical-vapor deposition, etc.) and removal (e.g. lift-off, wet etching, reactive-ion etching,  
20 chemical-mechanical planarization, etc.) process steps.

It may be preferable to form the ground electrodes 32 of a conductive material having a fluid compatibility property that corresponds to a fluid compatibility property of the fluid compatibility layer 118a. For example, the ground electrodes 32 may have a hydrophobicity that approximately matches a  
25 hydrophobicity of the fluid compatibility layer 118a. For example, the ground electrodes 32 may be formed using chromium which has a much high contact angle with respect to water than gold. The same approach may be applicable where the desired fluid compatibility property is hydrophylicity.

Figures 16B and 16C show an alternative embodiments. These  
30 alternative embodiments, and those other embodiments and described herein, are

substantially similar to previously described embodiments, and common acts and structures are identified by the same reference numbers. Only significant differences in operation and structure are described below.

In the embodiment shown in Figure 16B, the ground electrodes 32  
5 may be covered by at least a portion of the fluid compatibility layer 118a, for example, by making fluid compatibility layer 118a sufficiently thin or employing a conductive fluid compatibility layer 118a to achieve grounding of the fluid bodies 22 by the ground electrodes 32 through the fluid compatibility layer 118a. These alternatives may lower costs by the number of process steps, although the ground  
10 may not be as efficient as in the embodiment described immediately above.

In the embodiment of Figure 16C, the ground electrodes 32 are simply formed on the exposed surface 117 of the fluid compatibility layer 118a, lowering cost by reducing the number of process steps, although such an approach will result in a physical barrier that may hinder movement of the fluid  
15 bodies 22. While such a physical barrier will typically be deemed a disadvantage, physical barriers may be advantageously employed in some applications. Positioning the ground electrodes 32 off the centerline of the drive electrodes 26, and even between the drive electrodes 26, may minimize shorting across the dielectric layer 118a or causing dielectric breakdown resulting from punch-through.

20 These embodiments are particularly suited to being driven using a direct addressing scheme, for example, employing a dedicated addressing line for each drive electrode 32 and an "off chip" addressing circuit. Alternatively, these embodiments may employ an active matrix approach, such as generally described above.

25 Figure 16D shows a portion of an embodiment of a microfluidic structure 12 comprising a single substrate 102, sodium barrier films 110a, 110b on opposed surfaces of the substrate 102, a number of drive electrodes 26 carried by the substrate 102, and a fluid compatibility layer 118a of suitable thickness to also serve as a dielectric overlying the drive electrodes 26. A number of electrically  
30 conductive ground electrodes 32 extend parallel, along columns formed by the

drive electrodes 26. Each of the ground electrodes 32 overlies a portion of the drive electrodes 26 in a respective one of the columns of drive electrodes 26, and is electrically insulated therefrom via the fluid compatibility layer 118a. While illustrated as having an exposed surface 33 of the ground electrodes 32 coplanar with an exposed surface 117 of fluid compatibility layer 118a to make electrical contact with the fluid bodies 22, in some embodiments the ground electrodes 32 may underlie the exposed surface 117 of the fluid compatibility layer 118a if the grounds lines 32 are sufficiently close to the exposed surface 117 to provide electrical coupling to the fluid bodies 22. A suitable material may take the form of a fluoropolymer. The maximum spacing between the ground electrodes 32 and the exposed surface 117 will be a function of the particular material forming the fluid compatibility layer 118a.

Figures 17B-19C show embodiments of microfluidic structures 12 similar to that of Figures 16A-C and 17A. These embodiments, and those other embodiments and described herein, are substantially similar to previously described embodiments, and common acts and structures are identified by the same reference numbers. Only significant differences in operation and structure are described below.

Figure 17B shows a microfluidic structure 12 where the ground electrodes 32 extend parallel along and between columns 26a-26d formed by the drive electrodes 26, and do not overlie a portion of the drive electrodes 26.

Figure 17C shows a microfluidic structure 12 where the ground electrodes 32 extend parallel along columns formed by the drive electrodes 26 and partially overlie a portion of the drive electrodes 26.

Figure 18A shows a microfluidic structure 12 where the ground electrodes 32 extend parallel along rows formed by the drive electrodes 26 and overlie a portion of the drive electrodes 26.

Figure 18B shows a portion of a microfluidic structure 12 where the ground electrodes 32 extend parallel along rows formed by the drive electrodes 26 and do not overlie a portion of the drive electrodes 26.

Figure 18C shows a portion of a microfluidic structure 12 where the ground electrodes 32 extend parallel along rows formed by the drive electrodes 26 and partially overlie a portion of the drive electrodes 26.

Figure 19A shows a portion of a microfluidic structure 12 where the  
5 ground electrodes 32 extend parallel along both columns and rows formed by the drive electrodes 26 and overlie a portion of the drive electrodes 26.

Figure 19B shows a portion of a microfluidic structure 12 where the ground electrodes 32 extend parallel along both columns and rows formed by the drive electrodes 26 and do not overlie a portion of the drive electrodes 26.

10 Figure 19C shows a portion of a microfluidic structure 12 where the ground electrodes 32 extend parallel along both columns and rows formed by the drive electrodes 26 and partially overlie a portion of the drive electrodes 26.

In a further alternative, the dielectric and fluid compatibility layers 116, 118a, respectively, may be patterned to expose selected ones of the drive  
15 electrodes 26, which may be electrically coupled to a ground to serve as ground electrodes. This alternative may lower costs by reducing the number of process steps required, but will typically require a relatively dense array of drive electrodes 26.

Figure 9 illustrates a first embodiment of the feedback subsystem 86,  
20 employing a set of visual feedback sensors, for example, in the form of CCD sensor array or camera 132. The visual feedback sensors may take any of a variety of forms of photosensitive devices, including but not limited to one and two dimensional arrays of photosensitive sensors such as charge coupled devices ("CCDs"), Vidicon, Plumbicon, as well as, being configured to capture either still  
25 image or video image data.

The CCD sensor array or camera 132 is oriented to visual capture images of the through the transparent electrode 32. The image data 134 is supplied to the computing system 14 for analysis and/or display. The image data may be in suitable form for display on the active matrix display 56 without further  
30 processing. Thus, a live, or delayed, display of the actual movement of the bodies

of fluid 22a, 22b may be provided. Suitable image processing software (e.g., application programs 78) may be loaded in the system memory 36 of the computing system 14 to process the image data (e.g., program data 86), and to identify a position of each body of fluid 22a, 22b in the microfluidic structure 12 at a series of time intervals. The position information may be processed to provide an animated display of the bodies of fluid 22a, 22b, and/or control the drive electrodes 26 of the microfluidic structure 12 via drive signals 136 as discussed more fully below.

Figure 10 illustrates a second embodiment of a feedback subsystem 86, employing a set of position detection sensors 138, and row and column detection circuitry 140, 142, respectively. The position detection sensors 138 may be pressure sensitive, resistivity sensitive, or capacitance sensitive.

One method of detecting the position of bodies of fluid 22a, 22b (e.g., drops or droplets) involves measuring the resistance between adjacent sensor electrodes. If the sensor electrodes are in electrical contact with the fluid body 22a, 22b, the application of a voltage pulse to one sensor electrode can be detected by an adjacent sensor electrode if the body of fluid 22a, 22b is in contact with both sensor electrodes. If the body of fluid 22a, 22b is not in contact with both sensor electrodes, the resistance of the air/immiscible fluid between the electrodes is too great for a pulse to be detected.

The feedback subsystem 86 may employ a TFT array of sensor electrodes by activating a row of sensor electrodes 140 and then pulsing the potential of one column of sensor electrodes 142 at a time, while measuring the potential at the adjacent sensor electrodes. By raster scanning through all rows and columns, data representing the location of bodies of fluid 22a, 22b can be provided to the active matrix display 56 to visually indicate the current location of the bodies of fluid 22a, 22b and/or to provide a feedback signal to control the drive electrodes 26 to adjust the motion of the bodies of fluid 22a, 22b. More generally, for any sensor system, the row and column detection circuitry 140, 142 receive electrical signals from the position detection sensors 138 and provide position

information 144 to the computing system 14, identifying the position of one or more bodies of fluid 22a, 22b in the microfluidic structure 12. Suitable row and column detection circuitry 140, 142 is disclosed in U.S. Patent No. 5,194,862 issued March 16, 1993 to Edwards. Suitable processing software (e.g. application programs 78) may be loaded into the system memory 36 of the computing system 14 to provide an animated display of the bodies of fluid 22a, 22b, and/or control the drive electrodes 26 of the microfluidic structure 12 via drive signals 136 as discussed more fully below.

As an open platform, the microfluidic system 10 allows reconfiguration of protocols through the use of software to specify the potential of each electrode 26, 32, and thereby control the motion of individual bodies of fluid 22a, 22b. A protocol for a particular assay may be controlled by using commercial, off-the-shelf software, for example video editing software, to create an "animation" to charge the electrodes 26, 30 adjacent to a droplet edge sequentially so that motion occurs. Fluid bodies 22a, 22b with a lateral dimension (*i.e.*, a dimension in the plane of the liquid/solid interface) allowing coverage of some portion of the dielectric layer 116 overlying at least two drive electrodes 26 can be moved by (1) addressing the electrodes with 8-bit control on the electrode potential that already exists in flat panel displays to provide 256 gray levels of light intensity and (2) addressing the display electrodes with control over the 3 display columns associated with Red, Green, and Blue for a display pixel so that microfluidic control can be provided with a factor of 3 increase over the display pixel density. (*E.g.*, 1280 x 1024 x 3 for SXGA format).

The microfluidic structure 12 may employ TFT AMLCD technology and/or electrode addressing, and may thus use commercially available animation software (e.g., application programs 78). The use of an array of many drive electrodes 26 to control drops larger in diameter than one or two drive electrodes 26 has not been previously reported, while the microfluidic structure 12 may utilize multiple drive electrodes 26 to manipulate larger drops, for example causing a large drop to divide into two or more smaller drops. In particular, a ratio of at least

two drive electrodes to an area covered by a fluid body 22a, 22b (*i.e.*,  
electrowetted area) allows the splitting of the fluid body 22a, 22b into two fluid  
bodies. A ratio of at least three drive electrodes 26 to an area covered by a fluid  
body 22a, 22b allows particularly effective fine grain control of the fluid body 22a,  
5 22b.

While commercial animation software may be used to generate  
protocols, this may in some cases require trial-and-error programs to ensure  
robust droplet control, especially for some droplet-splitting processes where  
surface tension forces marginally vary around the droplet edge. As discussed  
10 above, the feedback subsystem 86 may be integrated to detect the location of  
droplets, and to ensure robust droplet control, for example, via closed-loop  
feedback control. This will prove beneficial for users with samples having varying  
physical properties because a single control algorithm will not be appropriate for  
every sample. Customized software for generating animations within closed-loop  
15 feedback (*i.e.*, real time control) to verify and direct droplet location may prove a  
major feature of the microfluidic system 10 platform as the system gains wide  
acceptance.

Figure 11 shows a method 200 of operating the microfluidic system  
12. In act 202, an end user produces an executable animation file using the user  
20 interface of an animation software program or package. In some embodiments,  
the animation software may be standard, unmodified commercially available  
animation software suitable for producing animations or videos for display on  
active matrix displays. The animation software may stored on any computer-  
readable media 46, 50, 54 (Figure 2) and may be executed on the computing  
25 system 14 (Figure 1), or on some other computing system (not shown).

In act 204, the computing system 14 executes the animation file. In  
response, the computing system 14 provides drive signals to the transistors 114  
(Figure 3) by way of the row and column drivers 28, 30 (Figure 1) in act 206. In act  
208, the transistors 114 selectively couple the drive electrodes 26 to one or more  
30 voltage sources 88. In response, a respective potential is successively applied to

respective portions of the dielectric layer 116, causing the fluid body 22a, 22b to move from drive electrode 26 to drive electrode 26, in act 210.

Additionally, or alternatively, the user may use a pointing device such as a mouse, trackball, joystick to move to create the animation using the animation software, and/or to drive the fluid bodies in real time. For example, the user may manipulate the pointing device 60 (Figure 2) to move a cursor on a display or monitor 56 to select one or more fluid bodies 22, a starting position, an ending position, and/or intermediate positions for the one or more fluid bodies 22. In response, the animation software may automatically define instructions for driving the drive electrodes 26 and/or ground electrodes 32 to move the fluid bodies 22 along the desired paths. The instructions may be executed in real time, or may be stored for later execution, for example, on a repeating basis for instance in a batch mode operation.

In a particular example, the user may manipulate the pointing device 60 to position the cursor over one or more fluid bodies 22, for example, right clicking the pointing device 60 to select the one or more fluid bodies 22 over which the cursor is positioned. The user may then manipulate the pointing device 60 to position the cursor over a destination, for example, left clicking the pointing device 60 to select the destination over which the cursor is positioned. As a further particular example, the user may manipulate the pointing device 60 by, for example, left clicking and dragging to selected all fluid bodies 22 in a region traversed by the cursor during the click and drag operation. The user may then manipulate the pointing device 60 by, for example, right clicking and dragging to move all of the selected fluid bodies to a desired location. As an even further particular example, the user may manipulate the pointing device 60 by, for example, double clicking to combine all of the selected fluid bodies. Other pointing device manipulations and operations on fluid bodies 22 will be apparent to one of skill in the art from the present teachings.

Figure 12 shows an additional method 230 of operating the microfluidic system 12. In act 232, the position feedback sensors sense the actual



position of one or more bodies of fluid 22a, 22b. In act 234, the position feedback sensor produces position feedback signals. In act 236, the computing system 14 receives the position feedback signals. In act 238, the processing unit 34 of the computing system 14 provides position feedback signals to the active matrix display 56. In some embodiments, the position feedback signals require no modification or preprocessing to drive the active matrix display 56, for example, where the position feedback signals are provided by an active matrix of position detection sensors 138. In other embodiments, the position feedback signals may require preprocessing, for example, where the feedback signals are provided by an array of image sensors such as a camera 132. Act 240 can be performed in concert with act 242 to display the actual and desired locations and/or flow paths at the same time.

In act 240 the active matrix display 56 displays the actual position and/or flow path of one or more of the fluid bodies 22a, 22b. In act 242, the processing unit 34 of the computing system 14 drives the active matrix display 56 using the executable animation file to display a desired position and/or desired flow path of one or more bodies of fluid 22a, 22b. In some embodiments, the executable animation file requires no modification or preprocessing to drive the active matrix display 56, for example, where the executable animation file was generated with standard animation software.

Figure 13 shows a further method 250 of operating the microfluidic system 12. In particular, the microfluidic system 10 employs the position feedback subsystem 86 to adjust the operation of the microfluidic system 10 based on position feedback. For example, in act 252, the computing system 14 determines a difference between an actual position and a desired position. In step 254 the computing system 14 adjusts a next set of drive signals based on the determined difference. For example, the computing system 14 may delay some signals, or change the frequency of electrode 26, 32 operation along one or more flow paths. In act 256, the computing system 14 provides the adjusted next set of drive signal to the transistors 114 to drive the drive electrodes 26, adjusting the movement of

one or more of the bodies of fluid 22a, 22b from a previously defined flow path. Thus, the computing system 14 may compensate for inconsistencies in the physical structure of the microfluidic structure 12 (e.g., differences in drive electrodes 26, transistors 114, and/or across the fluid compatibility layer 118), and/or different properties of the fluid bodies 22a, 22b, and/or any other unexpected or difficult to estimate operating parameters.

Figure 14 shows a further method 260 of operating the microfluidic system 12. In act 262, the computing system 14 converts the received position feedback signals into an executable animation file. In step 264, the processing unit 34 drives the active matrix display 56 according to the converted executable animation file to display an animation of the actual flow path of one or more of the bodies of fluid 22a, 22b.

The above-described methods can be used with each other, and the order of acts may be changed as would be apparent to one of skill in the art. For example, the method 260 can generate an animation of the actual flow path to be displayed in act 240 of method 230. Also for example, the method 250 can be combined with method 260 to display an adjusted position and/or flow path before providing the adjusted next set of drive signal to the transistors 114. The described methods can omit some acts, can add other acts, and can execute the acts in a different order than that illustrated, to achieve the advantages of the invention.

Figure 15 shows a display 270 on a screen of the active matrix display 56 (Figures 1 and 2) of a set of desired flow paths 272, 274, actual flow paths 276, 278, desired positions  $D_1$ ,  $D_2$  and actual positions  $A_1$ ,  $A_2$  for a two bodies of fluid 22a, 22b, respectively, in the microfluidic structure 12 in accordance with the methods discussed above. In particular, the body of fluid 22a enters via a first port 16a, and is directed along a desired flow path 272 to an exit port 16b. As illustrated by the actual flow path 276, the body of fluid 22a has deviated from the desired flow path 272 for any of a variety of reasons, and is at the actual position  $A_1$  instead of the desired position  $D_1$  at a given time. The second fluid body 22b enters via a port 16c and is directed along a desired flow path 274, in order to

combine with the first fluid body 22a at a point 280 . As illustrated by the actual flow path 278, the second fluid body 22b is following the desired flow path 274 as directed and the actual position  $A_2$  corresponds with the desired position  $D_2$ . The computing system 14 can make appropriate adjustment in the drive signals to  
5 adjust the speed and/or direction of the first and/or second fluid bodies 22a, 22b to assure that the first and second fluid bodies 22a, 22b combine at the point 280, which may, or may not have an additional reactant or other molecular components.

Much of the detailed description provided herein is disclosed in the provisional patent application; most additional material will be recognized by those  
10 skilled in the relevant art as being inherent in the detailed description provided in such provisional patent application or well known to those skilled in the relevant art based on the detailed description provided in the provisional patent application. Those skilled in the relevant art can readily create source based on the detailed description provided herein.

15 Although specific embodiments of and examples for the microfluidic system and method of the invention are described herein for illustrative purposes, various equivalent modifications can be made without departing from the spirit and scope of the invention, as will be recognized by those skilled in the relevant art. The invention may utilize thin film transistor active matrix liquid crystal display  
20 technology to manipulate small samples of fluid for chemical, biochemical, or biological assays with no moving parts. The platform utilizes existing active matrix addressing schemes and commercial-off-the-shelf animation software such as video editing software to program assay protocols. The teachings provided herein of the invention can be applied to other microfluidic platforms, not necessarily the  
25 exemplary active matrix microfluidic platform generally described above. The various embodiments described above can be combined to provide further embodiments.

Other teachings on electrowetting include G. Beni and M.A. Tenan, "Dynamics of Electrowetting Displays," J. Appl. Phys., vol. 52, pp. 6011-6015  
30 (1981); V.G. Chigrinov, *Liquid Crystal Devices, Physics and Applications*, Artech

House, 1999; E. Lueder, *Liquid Crystal Displays, Addressing Schemes and Electro-Optical Effects*, John Wiley & Sons, 2001; M.G. Pollack, RB Fair, and A. Shenderov, "Electrowetting-based actuation of liquid droplets for microfluidic applications," *Appl. Phys. Lett.*, vol. 77, number 11, pp. 1725-1726 (2000); and P.

- 5 Yeh and C. Gu, *Optics of Liquid Crystal Displays*, John Wiley & Sons, 1999.

All of the above U.S. patents, U.S. patent application publications, U.S. patent applications, foreign patents, foreign patent applications and non-patent publications referred to in this specification and/or listed in the Application Data Sheet, including but not limited to U.S. Provisional Application

- 10 No. 60/333,621, filed November 26, 2001; and U.S. Patent Application No. 10/305,429, filed November 26, 2002, are incorporated herein by reference in their entirety.

- Various changes can be made to the invention in light of the above-detailed description. In general, in the following claims, the terms used should not  
15 be construed to limit the invention to the specific embodiments disclosed in the specification and the claims, but should be construed to include all microfluidic platforms that operate in accordance with the claims. Accordingly, the invention is not limited by the disclosure, but instead its scope is to be determined entirely by the following claims.